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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hani Ikram Noshi

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Art Unit: 2881

Serial No.: 10/065,584

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Examiner: Christopher M. Kalivoda

Filed: October 31, 2002

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For: SOURCE PIN LOADING
METHODS AND APPARATUS
FOR POSITRON EMISSION
TOMOGRAPHY

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AMENDMENT

Mail Stop: Non Fee Amendment
Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 8, 2003, please amend the above-identified patent application as follows: